



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TC 3700 MAIL ROOM

In re application of

Shozo OGURI et al.

Serial No. 09/764,318

Filed January 19, 2001

POLISHING APPARATUS

: Docket No. 2001-0046A

: Group Art Unit 3723

: Examiner Berry, Willie W., Jr.

: Confirmation No.

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents,
Washington, D.C.

Sir:

**THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975**

This is in response to the Restriction Requirement mailed December 5, 2001.

Applicants, by their undersigned representative, hereby elect the invention of Group I which is drawn to a polishing apparatus and corresponds to claims 1-6. This election is made without traverse.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.

Respectfully submitted,

Shozo OGURI et al.

By:

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